



## Glass 3D micro-manufacturing for monolithically integrated quantum devices

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**Quantum Metrology and Quantum Sensors**  
Online Event, February 27<sup>th</sup>, 2023

**FEMTOprint SA**  
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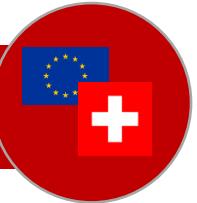


FEMTOprint is a Swiss high-tech **Contract Development & Manufacturing Organization (CDMO)** specialized in high-precision **3D microfabrication in glass**.



#### FOUNDED IN 2013

Spin-off of the EU project *femtoprint*



#### > 35 FTEs

Interdisciplinary and multicultural team



#### 2 LOCATIONS IN SWITZERLAND

Muzzano (*Headquarters*) & Neuchâtel (*BU Photonics*)



#### WORLDWIDE SALES

Export in 30+ countries & Sales agents in KR, JP, IL, DACH



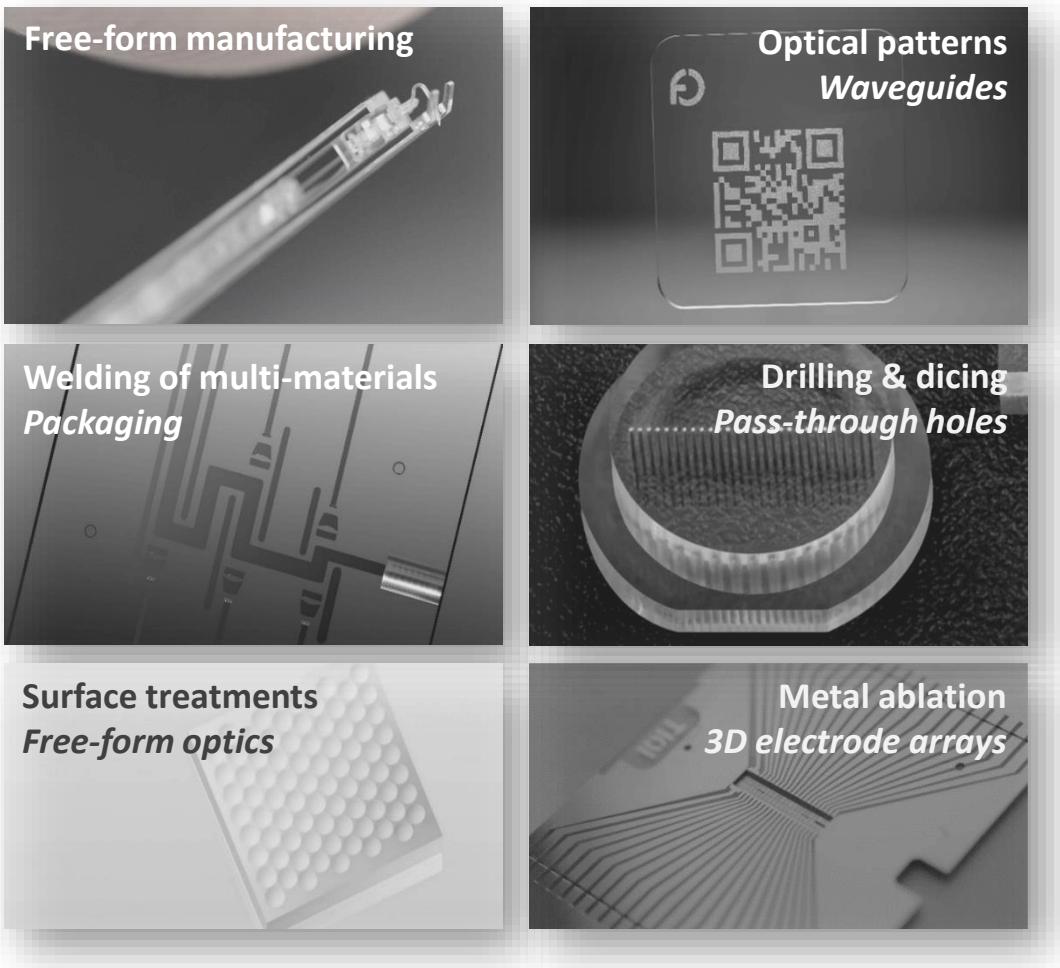
#### ISO CERTIFIED

ISO 13485 : 2016



# Enabling technology for quantum devices

## CAPABILITIES



## PERFORMANCES\*

\*in SiO<sub>2</sub>

### RESOLUTION AND TOLERANCES

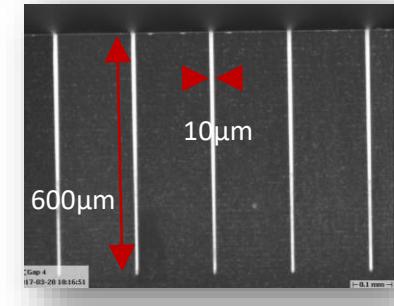
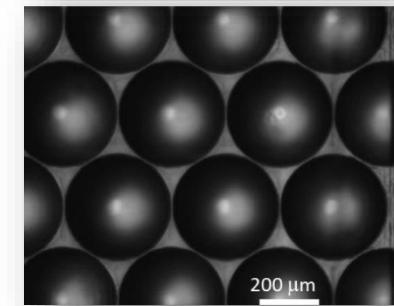
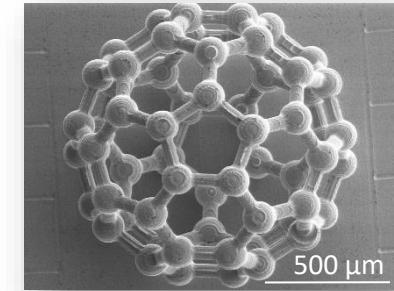
- Process resolution  $\sim 1 \mu\text{m}$
- XY tolerances +/- 1  $\mu\text{m}$
- Z tolerance +/- 2  $\mu\text{m}$

### SURFACE QUALITY

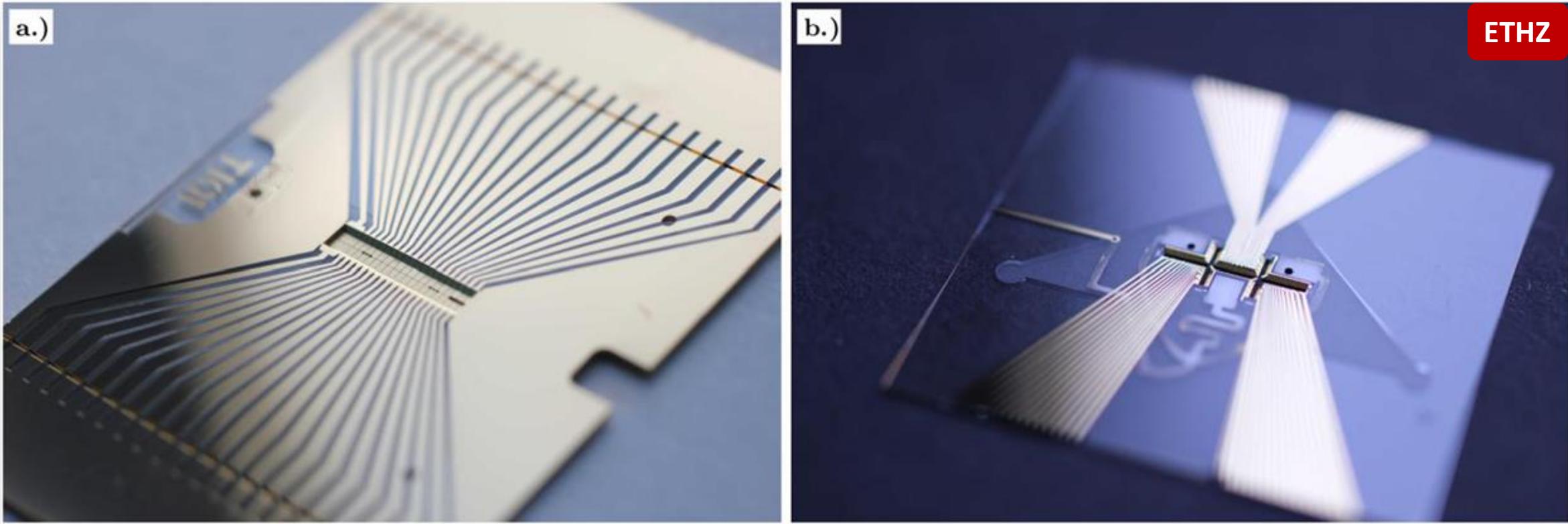
- Patterned surface  $S_a \sim 150 \text{ nm}$
- Surface treatment  $S_a < 20 \text{ nm}$

### ASPECT RATIO

- Channel aspect ratio  $> 1:500$
- Bulk height up to 30 mm
- Working area up to 300 mm Ø

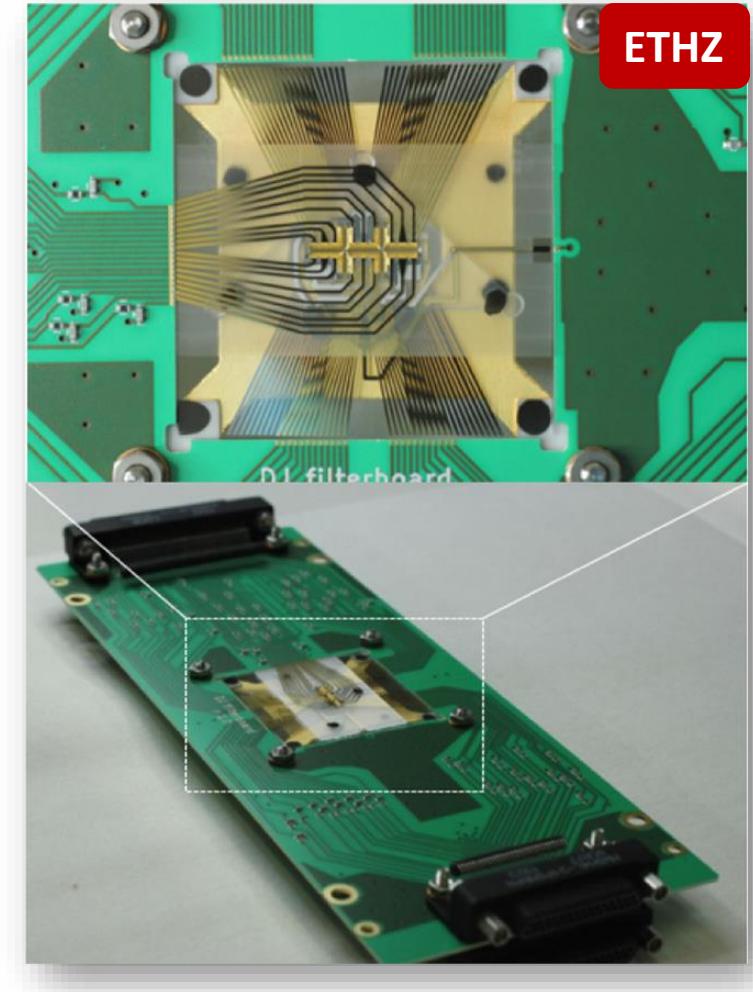
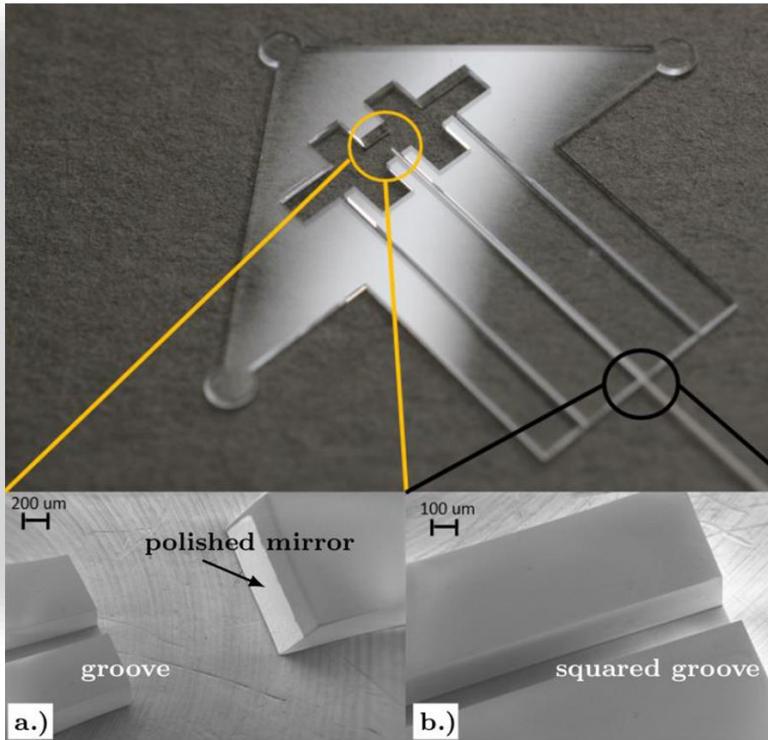
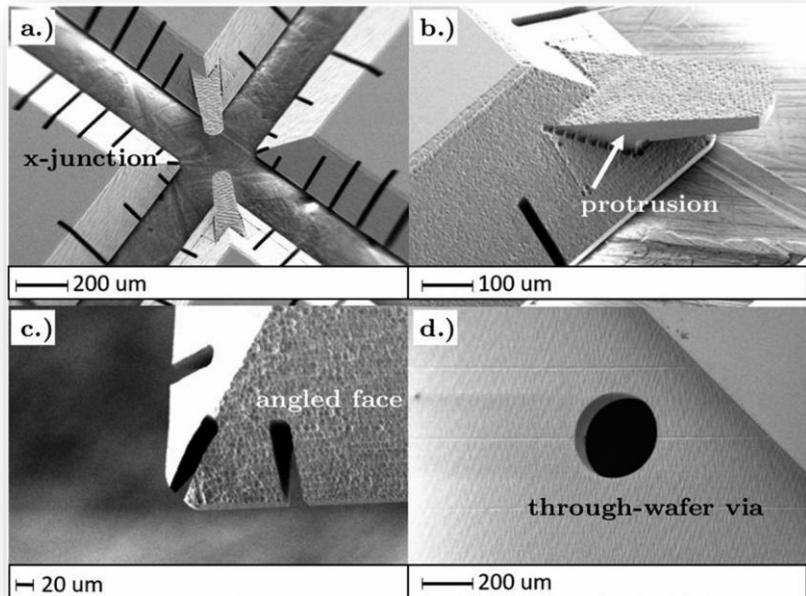


Quantum computing + Precision measurements and frequency standards (e.g. Atomic clocks)



S. Ragg, et al., **Segmented ion-trap fabrication using high precision stacked wafers**, Rev. Sci. Instrum. **90**, 103203 (2019);

# Glass 3D ion traps

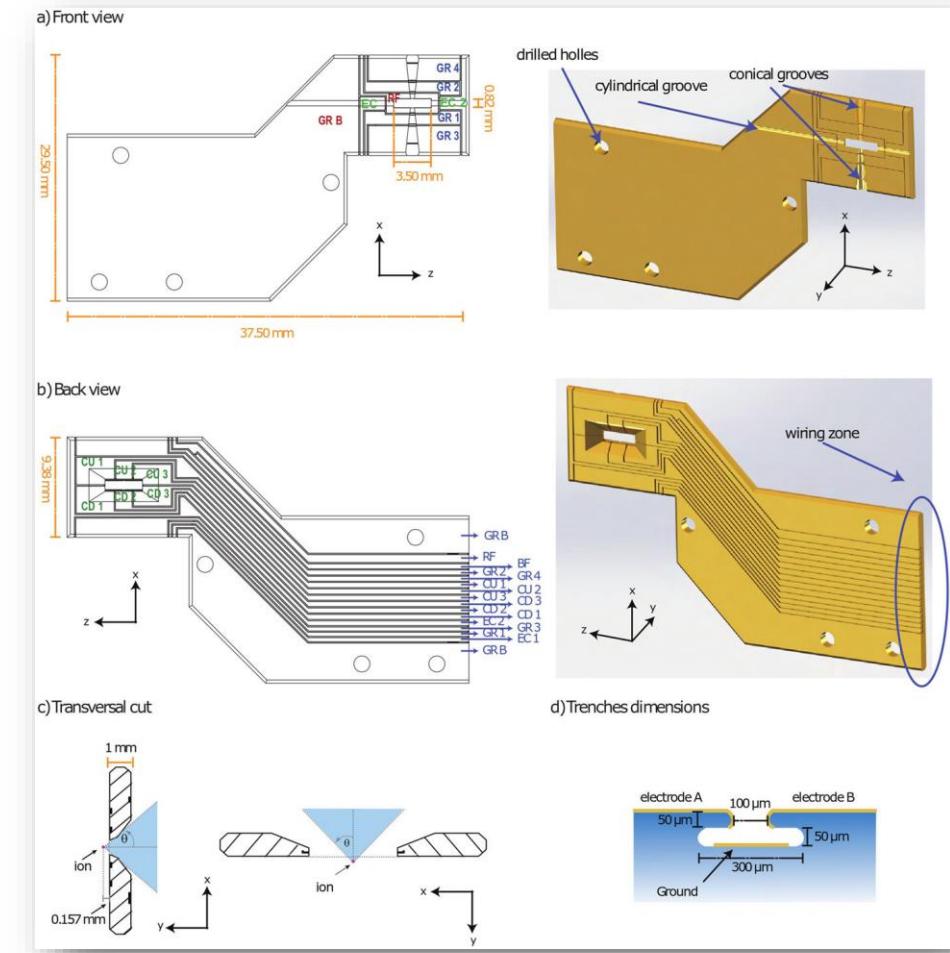
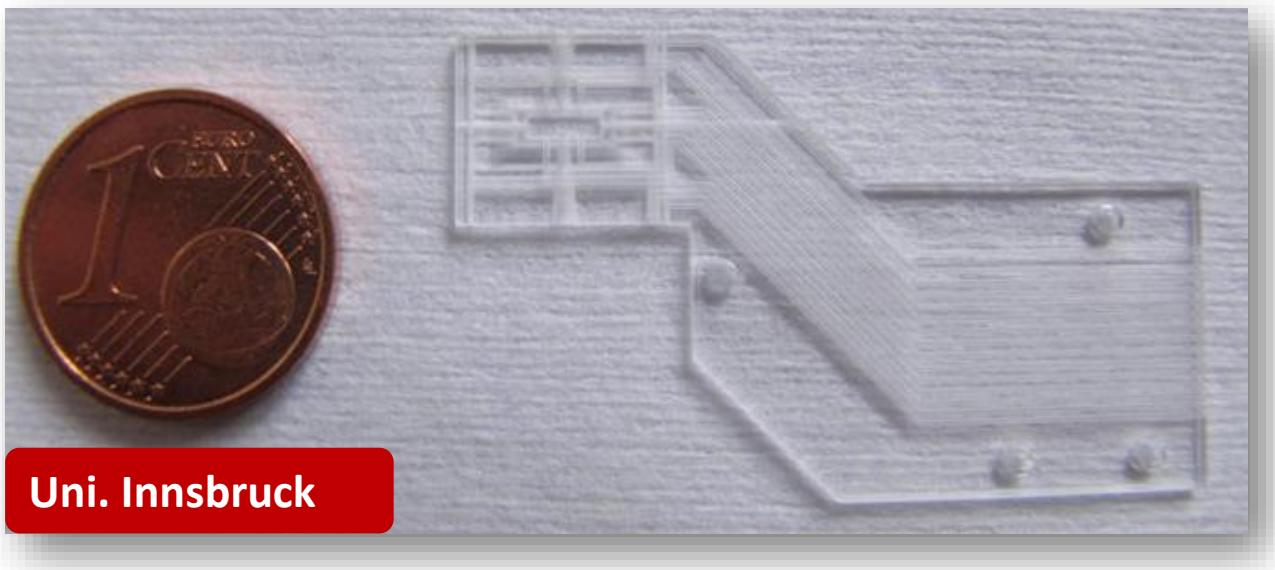
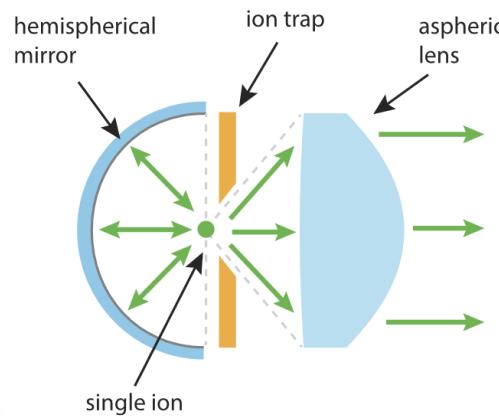


- Ad-hoc 3D features
- Surface smoothening
- Optical integration
- Multi-layers self-assembly with micrometric precision
- Metallization (possibility of masking)

S. Ragg, et al., **Segmented ion-trap fabrication using high precision stacked wafers**, Rev. Sci. Instrum. **90**, 103203 (2019);

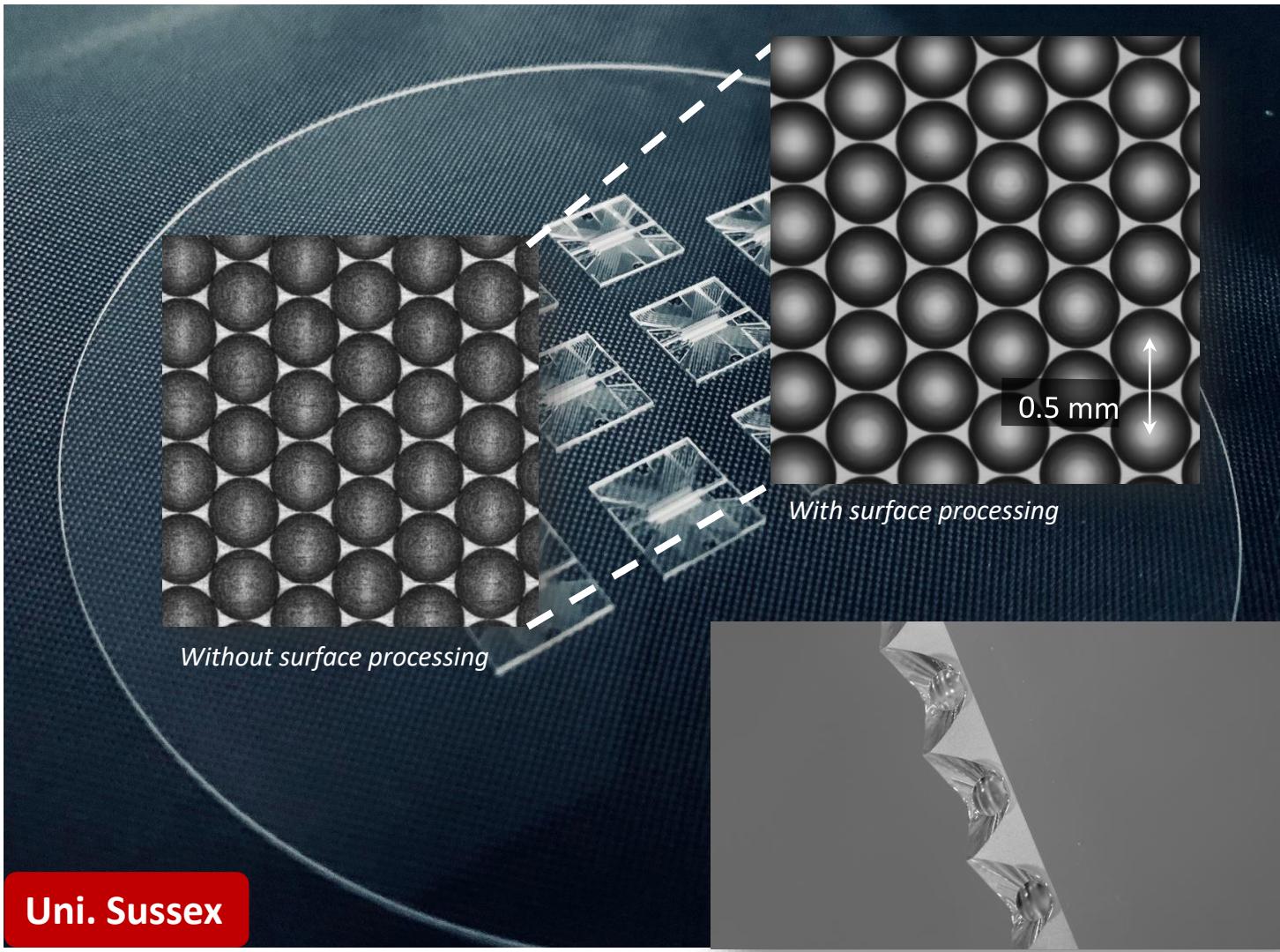
# Glass 3D ion traps

Study the inhibition and enhancement of spontaneous emission of trapped  $\text{Ba}^+$  ions.



G. Araneda, et al., **The Panopticon device: An integrated Paul-trap–hemispherical mirror system for quantum optics featured**, Rev. Sci. Instrum. 91, 113201 (2020);

# Wafer scale + Optical integration



Uni. Sussex

## WHAT CAN WE DO FOR YOU?

- 3D printing of monolithically integrated glass micro-devices: from feasibility & fast prototyping to pilot & volume production
- Combine dedicated know-how in optics & photonics with full control over fabrication processes and production systems
- Provide solutions for integrated devices:
  - High precision 3D micro-manufacturing of glass;
  - Integration of mechanical & electrical functionalities;
  - Packaging & assembly (incl. Welding and high precision 1D & 2D fiber arrays);
  - Co-packaged miniaturized optics and micro-optics.

## WHAT CAN YOU DO FOR US?

- Design, Metrology, Functional testing
- Requests for fast-prototyping, pilot manufacturing, and mastering/tooling services
- Collaboration on the development & manufacturing of
  - ion traps;
  - application specific quantum systems;
  - miniaturized & micro-optical components, devices, and systems;
  - multifunctional glass micro-systems.



Thank  
you!



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